

# **Effect of Al Sn – Doping on properties of zinc oxide nanostructured films grown by magnetron sputtering**

**Ghimpus Lidia, Tiginyanu Ion, Lupan Oleg, Mishra Yogendra Kumar, Paulowicz Ingo, Gedamu Dawit, Cojocaru Ala, Adelung Rainer**

<https://doi.org/10.1109/SMICND.2013.6688111>

## **Abstract:**

Metal doping in nanostructured zinc oxide is important for device applications. To obtain improved performances for practical applications, Aluminum (Al) and Tin (Sn)-doping in zinc oxide nanostructured layers were investigated. Samples were grown by magnetron sputtering and studied by X-ray diffraction (XRD), micro-Raman, scanning electron microscopy (SEM), and energy dispersive X-ray (EDX) techniques. It was observed that nanoparticles are interconnected and form porous network of individual nanoparticles. It is found clear evidence of changes of different properties after doping with aluminum or tin in zinc oxide nanostructured films grown by magnetron sputtering.

## **References:**

1. O. Lupan, V. M. Guérin, L. Ghimpus, I. M. Tiginyanu, T. Pauporté, "Nanofibrous-like ZnO layers deposited by magnetron sputtering and their integration in dye-sensitized solar cells", Chem. Phys. Lett., vol. 550, pp. 125-129, 2012.
2. O. Lupan, L. Chow, Th. Pauporté, L. K. Ono, B. Roldan Cuenya, G. Chai, "Highly sensitive and selective hydrogen single-nanowire nanosensor", Sensors and Actuators B, vol. 173, pp. 772-780, 2012.
3. O. Lupan, V. V. Ursaki, G. Chai, L. Chow, G. Emelchenko, I. M. Tiginyanu, A. N. Gruzintsev, A. N. Redkin, "Selective hydrogen gas nanosensor using individual ZnO nanowire with fast response at room temperature", Sensors and Actuators B: Chemical, vol. 144, pp. 56-66, 2010.
4. O. Lupan, G. Chai, L. Chow, "Novel hydrogen gas sensor based on single ZnO nanorod", Microelectr. Eng. vol. 85, pp. 2220-2226, 2008.

**CAS 2013**  
**International Semiconductor Conference**  
**14-16 October 2013**  
**Sinaia, Romania**

5. D. Gedamu, S. Jebril, A. Schuchardt, M. Elbahri, S. Wille, Y. K. Mishra, R. Adelung, "Examples for the integration of self-organized nanowires for functional devices by a fracture approach", *Physica Status Solidi B*, vol. 247(10), pp. 2571-2580, 2010.
6. O. Lupon, Th. Pauporté, B. Viana, "Low-Voltage UV-Electroluminescence from ZnO-Nanowire Array/p-GaN Light-Emitting Diodes", *Advanced Materials*, vol. 22, pp. 3298-3302, 2010.
7. Y. K. Mishra, R. Adelung, C. Röhl, D. Shukla, F. Spors, V. Tiwari, "Virostatic potential of micro-nano filopodia-like ZnO structures against herpes simplex virus-1", *Antiviral Research*, vol. 92, pp. 305-312, 2011.
8. T. Antoine, Y. K. Mishra, J. Trigilio, V. Tiwari, R. Adelung, D. Shukla, "Prophylactic, therapeutic and neutralizing effects of zinc oxide tetrapod structures against herpes simplex virus type-2 infection", *Antiviral Research*, vol. 96, pp. 363-375, 2012.
9. X. Jin, J. Strueben, L. Heepe, A. Kovalev, Y. K. Mishra, R. Adelung, S. N. Gorb, A. Staubitz, "Joining the Un-Joinable: Adhesion Between Low Surface Energy Polymers Using Tetrapodal ZnO Linkers", *Adv. Mater.*, vol. 24, pp. 5676-5680, 2012.
10. X. Jin, M. Götz, S. Wille, Y. K. Mishra, R. Adelung, C. Zollfrank, "A Novel Concept for Self-Reporting Materials: Stress Sensitive Photoluminescence in ZnO Tetrapod Filled Elastomers", *Adv. Mater.*, vol. 25, pp. 1342-1347, 2013.
11. A. Mang, K. Reimann, St. Rübenacke, "Band gaps, crystal-field splitting, spin-orbit coupling, and exciton binding energies in ZnO under hydrostatic pressure", *Solid State Commun.*, vol. 94(4) pp. 251-254, 1995.
12. A. El Manouni, F. J. Manjón, M. Mollar, B. Marí, R. Gómez, M. C. López, J. R. Ramos-Barrado, "Effect of aluminum doping on zinc oxide thin films grown by spray pyrolysis", *Superlattices and Microstructures*, vol. 39, pp. 185-192, 2006.
13. J. H. Lee, B. O. Park, "Transparent conducting ZnO:Al, In and Sn thin films deposited by the sol-gel method", *Thin Solid Films*, vol. 426, pp. 94-99, 2003.
14. H. Kim, A. Pique, J. S. Horwitz, H. Murata, Z. H. Kafafi, C. M. Gilmore, D. B. Chresey, "Effect of aluminum doping on zinc oxide thin films grown by pulsed laser deposition for organic light-emitting devices", *Thin Solid Films*, vol. 377-378. pp. 798-802, 2000.
15. J.-H. Lee, B.-O. Park, "Characteristics of Al-doped ZnO thin films obtained by ultrasonic spray pyrolysis: effects of Al doping and an annealing treatment", *Mater. Sci. Eng. B*, vol. 106, pp. 242-245, 2004.
16. Y. K. Mishra, S. Mohapatra, R. Singhal, D. K. Avasthi, D. C. Agarwal, S. B. Ogale, "Au-ZnO: A tunable localized surface plasmonic nanocomposite", *Appl. Phys. Lett.*, vol. 92, pp. 43107, 2008.
17. S. Jebril, H. Kuhlmann, S. Müller, C. Ronning, L. Kienle, V. Duppel, Y. K. Mishra, R. Adelung, "Epitactically Interpenetrated High Quality ZnO Nanostructured Junctions on Microchips Grown by the Vapor-Liquid-Solid Method", *Crystal Growth & Design* vol. 10, pp. 2842-2846, 2010
18. D. Song, P. Widenborg, W. Chin, A. G. Aberle, Investigation of lateral parameter variations of Al-doped zinc oxide films prepared on glass substrates by rf magnetron sputtering", *Sol. Energy Mater. Sol. Cells*, vol. 73(1), pp. 1-20, 2002.
19. B. M. Ataev, A. M. Bagamadova, V. V. Mamedov, A. K. Omaev, M. R. Rabadanov, "Highly conductive and transparent thin ZnO films prepared in situ in a low pressure system", *J. Cryst. Growth*, vol. 198-199, pp. 1222-1225, 1999.
20. A. V. Singh, R. M. Mehra, A. Yoshida, A. Wakahara, "Doping mechanism in aluminum doped zinc oxide films", *J. Appl. Phys.*, vol. 95 (7), pp. 3640-3643, 2004.

**CAS 2013**  
**International Semiconductor Conference**  
**14-16 October 2013**  
**Sinaia, Romania**

21. J. H. Lee, K. H. Ko, B. O. Park, "Electrical and optical properties of ZnO transparent conducting films by the sol-gel method", *J. Cryst. Growth*, vol. 247, pp. 119-125, 2003.
22. J. Y. Ma, S. C. Lee, " Effects of aluminum content and substrate temperature on the structural and electrical properties of aluminumdoped ZnO films prepared by ultrasonic spray pyrolysis ", *J. Mater. Sci., Mater. Electron.* vol. 11 (4), pp. 305-309, 2000.
23. J. Cembrero, A. Elmanouri, B. Hartiti, M. Mollar, B. Marí, "Nanocolumnar ZnO films for photovoltaic applications", *Thin Solid Films*, vol. 451-452, pp. 198-202, 2004.
24. O. Lupon, S. Shishyanu, V. Ursaki, H. Khallaf, L. Chow, T. Shishyanu, V. Sontea, E. Monaico, S. Railean, "Synthesis of nanostructured Al-doped zinc oxide films on Si for solar cells applications", *Solar Energy Materials and Solar Cells*, vol. 93 (8), pp. 1417-1422, 2009.
25. O. Lupon, L. Chow, S. Shishyanu, E. Monaico, T. Shishyanu, V. Sontea, B. Roldan Cuenya, A. Naitabdi, S. Park, A. Schulte, "Nanostructured zinc oxide films synthesized by successive chemical solution deposition for gas sensor applications", *Mat. Res. Bull.*, 44 (1), pp. 63-69, 2009.
26. Y. K. Mishra, S. Kaps, A. Schuchardt, I. Paulowicz, X. Jin, D. Gedamu, S. Freitag, S., Wille, M. Claus, A. Kovalev, S. N. Gorb, R. Adelung, "Fabrication of macroscopically flexible and highly porous 3D semiconductor networks from interpenetrating nanostructures by simple flame transport approach", *Part. Part. Syst. Charact.*, 2013 (In press). DOI: 10.1002/ppsc.201300197.
27. O. Lupon, G. Chai, L. Chow, G. Emelchenko, H. Heinrich, V. V. Ursaki, A. Gruzintsev, I. M. Tiginyanu, A. N. Redkin, "Ultraviolet photoconductive sensor based on single ZnO nanowire", *Physica Status Solidi A*, vol. 207(7), pp. 1735-1740, 2010.
28. V. V. Ursaki, O. I. Lupon, L. Chow, I. M. Tiginyanu, V. V. Zalamai, "Rapid thermal annealing induced change of the mechanism of multiphonon resonant Raman scattering from ZnO nanorods, " *Solid State Communications*, vol. 143(8-9), pp. 437-441, 2007.
29. Y. K. Mishra, V. S. K. Chakravadhanula, V. Hrkac, S. Jebril, D. C. Agarwal, S. Mohapatra, D. K. Avasthi, L. Kienle, and R. Adelung Crystal growth behaviour in Au-ZnO nanocomposite under different annealing environments and photoswitchability, *J. Appl. Phys.* vol. 112, pp. 064308, 2012.
30. L. Gimpu, I. M. Tiginyanu, V. Ursaki, O. Lupon, L. Chow, Y. Rudzevich, Y. Lin, "Optical and sensory properties of ZnO nanofibrous layers grown by magnetron sputtering", *Proceedings of the International Semiconductor Conference, CAS, Sinaia, Romania*, DOI: 10.1109/SMICND.2012.6400674, vol. 1, pp. 139-142, 2012.